

	Type	Hits	Search Text
1	BRS	6	(semiconductor adj2 laser) and (buried near2 ribbon) and (confinement adj2 layer) and (active adj2 layer) and substrate
2	BRS	6	(semiconductor adj2 laser) and (buried near2 ribbon) and (confinement adj2 layer) and (active adj2 layer) and substrate
3	BRS	6	(semiconductor adj2 laser) and (buried near2 ribbon) and substrate
4	BRS	27	(semiconductor adj2 laser) and ribbon and (confinement adj2 layer) and substrate
5	BRS	2	5304283.pn.
6	BRS	2	5349596.pn.
7	BRS	2	5306923.pn.
8	BRS	2	5511088.pn.
9	BRS	2	5568501.pn.
10	BRS	2	5661741.pn.
11	BRS	2	6292497.pn.

	DBs	Time Stamp	Comments	Error Definition
1	USPAT; US-P PUB; EP ; JP ; DERWENT; IBM_TDB	2003/01/03 11:41		
2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/03 12:37		
3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/03 12:38		
4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/03 12:46		
5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/03 12:46		
6	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/03 12:46		
7	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/03 12:46		
8	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/03 12:47		
9	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/03 12:47		
10	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/03 13:33		
11	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/03 13:33		

	Type	Hits	Search Text
1	BRS	2	5568501.pn.
2	BRS	129	noureddine.in.
3	BRS	0	noureddine-bouadma.in.
4	BRS	16	noureddine.in. and laser
5	BRS	3359	france adj2 telecom
6	BRS	31	(france adj2 telecom) and laser and (bury or buried)
7	BRS	300	(france adj2 telecom) and laser
8	BRS	325	(france adj2 telecom) and laser
9	BRS	2	6487230.pn.
10	BRS	2	6366597.pn.
11	BRS	2	6171973.pn.
12	BRS	2	6025207.pn.
13	BRS	2	5809051.pn.

	DBs	Time Stamp	Comments	Error Definition
1	USPAT; US-P PUB; EPO; JP ; DERWENT; IBM_TDB	2003/01/06 09:19		
2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 09:19		
3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 09:19		
4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 09:26		
5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 09:27		
6	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 09:27		
7	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 09:27		
8	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 09:45		
9	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 09:47		
10	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 09:51		
11	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 09:59		
12	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 10:04		
13	USPAT; US-P PUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 10:06		

	Type	Hits	Search Text
14	BRS	2	5511088.pn.
15	BRS	2	5440147.pn.
16	BRS	2	5306923.pn.
17	BRS	2	5796768.pn.
18	BRS	2	6025207.pn.

	DBs	Time Stamp	Comments	Error Definition
14	USPAT; US-P PUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 10:09		
15	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 10:11		
16	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 10:13		
17	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 10:13		
18	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/06 10:14		

	Type	Hits	Search Text
1	BRS	2	6271961.pn.
2	BRS	2	6236793.pn.
3	BRS	2	6204560.pn.
4	BRS	2	5897329.pn.
5	BRS	3491	(waveguide or laser) and confinement and clad\$4
6	BRS	1056	(waveguide or laser) and confinement and clad\$4 and (bury or buried)

	DBs	Time Stamp	Comments	Error Definition
1	USPAT; US-PGPUB; EPO; JP ; DERWENT; IBM_TDB	2003/01/07 14:34		
2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/07 14:36		
3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/07 14:42		
4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/07 14:45		
5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/07 14:46		
6	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/07 14:48		

	Type	Hits	Search Text
1	BRS	2	5796768.pn.
2	BRS	2	5661741.pn.
3	BRS	8376	buried and semiconductor and (laser or waveguide)
4	BRS	4	((buried or bury\$3) near2 (n-dope\$2 or (n adj dope\$2))) and semiconductor and (laser or waveguide)
5	BRS	5	((buried or bury\$3) near3 (n-dope\$2 or (n adj dope\$2))) and semiconductor and (laser or waveguide)
6	BRS	51	semiconductor and (laser or waveguide) and (p-dope\$3 near2 (contact adj2 layer))
7	BRS	22	semiconductor and (laser or waveguide) and (p-dope\$3 near2 (contact adj2 layer)) and buried
8	BRS	147	semiconductor and (laser or waveguide) and buried and (ingaas adj2 contact adj2 layer)

	DBs	Time Stamp	Comments	Error Definition
1	USPAT; US-P PUB; EP ; JP ; DERWENT; IBM_TDB	2003/01/10 10:17		
2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/10 13:59		
3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/10 14:00		
4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/10 14:02		
5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/10 14:57		
6	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/10 14:59		
7	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/10 15:06		
8	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/10 15:25		